

03500.014055.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
NOBUHIRO ITO ET AL. ) Examiner: S. Roy  
Appln. No.: 09/413,774 ) Group Art Unit: 2879  
Filed: October 7, 1999 )  
For: ELECTRON BEAM )  
APPARATUS AND SPACER ) March 5, 2003

The Commissioner for Patents  
Washington, D.C. 20231

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TECHNICAL STAFF  
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SUPPLEMENTAL AMENDMENT

Sir:

Supplemental to the Amendment filed in the Patent and Trademark Office on  
February 19, 2003 and the Supplemental Remarks filed on February 24, 2003, please  
further amend the above-identified application as follows:

IN THE CLAIMS

Please add Claims 113-122 to read as follows:

113. (New) An electron beam apparatus comprising a hermetic container  
which includes an electron source having electron emission devices and targets exposed to  
electrons emitted from said electron source and further comprising a first member within  
said hermetic container, wherein said first member is provided with an uneven geometry on